



INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	Docket No. 52433/795	Application No. 10/534,858	
	Applicant(s) M. HASHIMURA et al.	Examiner Deborah Yee	
	Filing Date May 13, 2005	Confirmation No. 9080	Art Unit 1793

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	JP 61-104049	May 22, 1986	JP			Abstract	
	JP 07-034189	February 3, 1995	JP			Abstract	
	JP 11-293391	October 26, 1999	JP			Abstract	
	JP 2001-329335	November 27, 2001	JP			Abstract	
	JP 2000-034538	February 2, 2000	JP			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Japanese Office Action dated May 20, 2008 issued in corresponding Japanese Application No. 2002-332668.
	Japanese Office Action dated May 20, 2008 issued in corresponding Japanese Application No. 2002-332658.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	